



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Hidetaka Higashino et al.

Serial No.: 09/744,227

Filed: January 22, 2001

For: METHOD OF PRODUCING GAS  
DISCHARGE PANEL

Patent Examiner: Dong, Dalie

Group Art Unit: 2875

September 3, 2003

Irvine, California 92614

**RESPONSE TO OFFICE ACTION**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sirs:

In response to the Office Action of March 5, 2003, please amend the above identified application as follows:

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TECHNOLOGY CENTER 2800